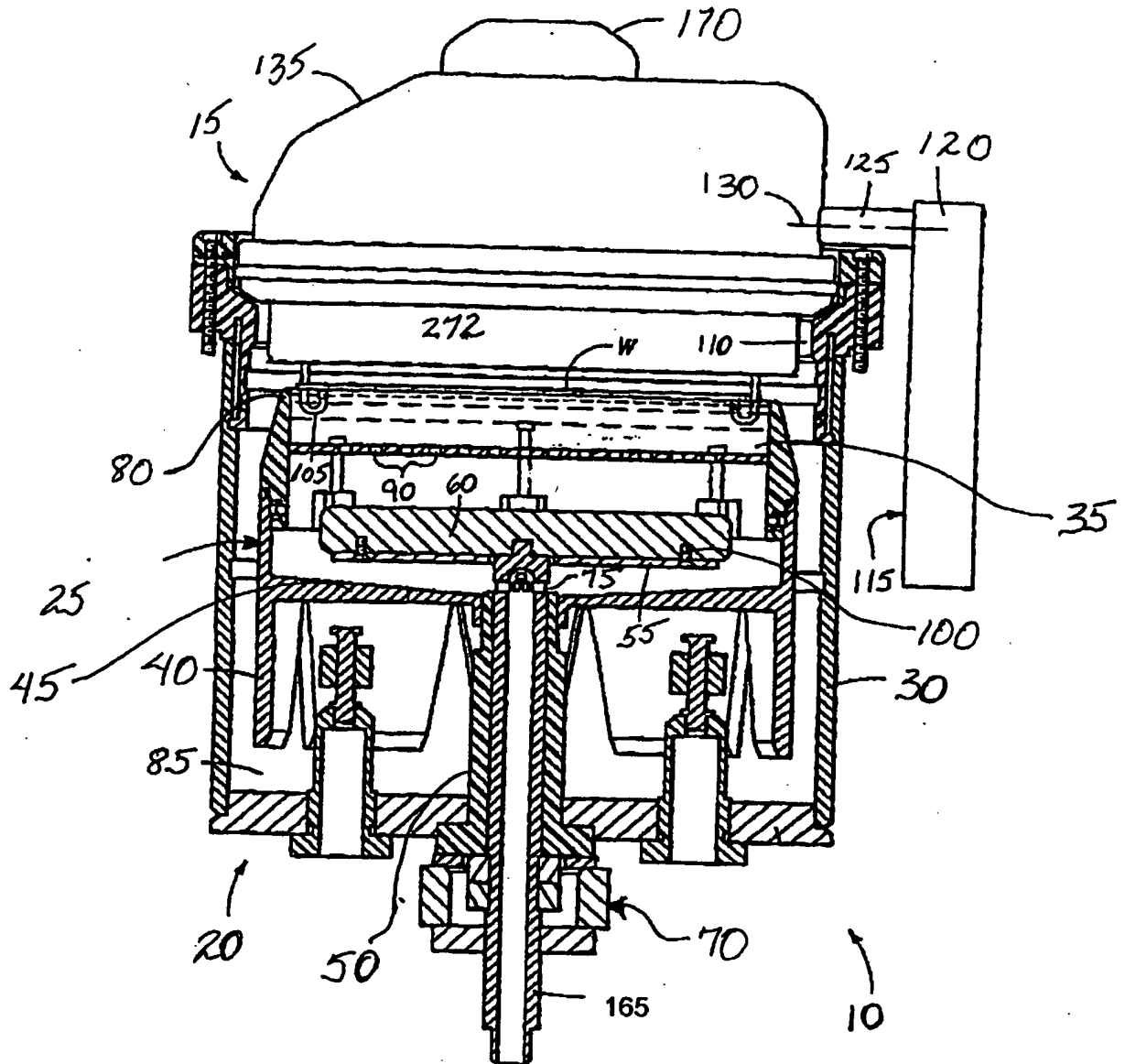


FIG. 1



Title: METHOD FOR FILLING RECESSED MICRO-STRUCTURES WITH METALLIZATION IN THE PRODUCTION OF A MICROELECTRONIC DEVICE

Inventors: T.L. Ritzdorf et al.
Docket No.: SEMT117192

Fig. 2E

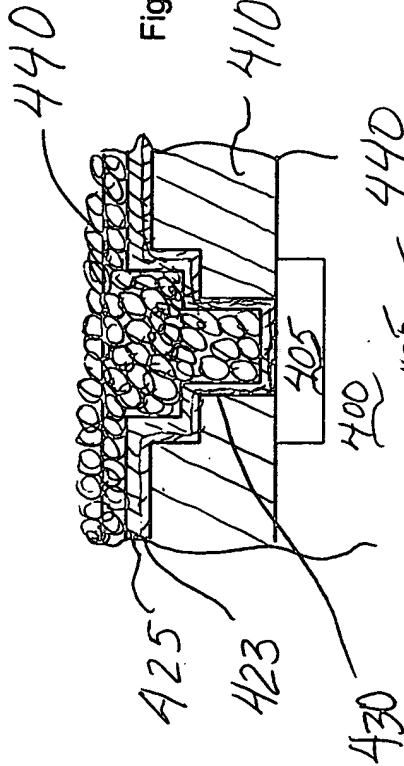


Fig. 2F

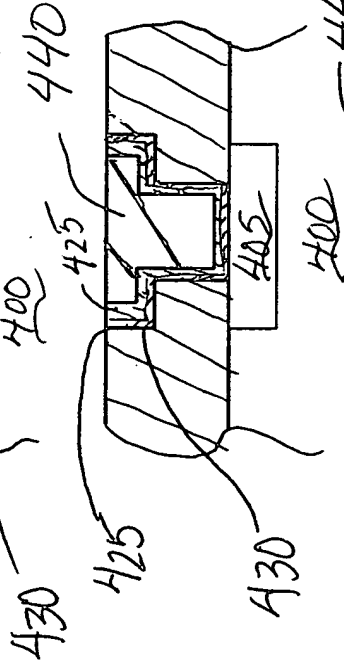


Fig. 2G

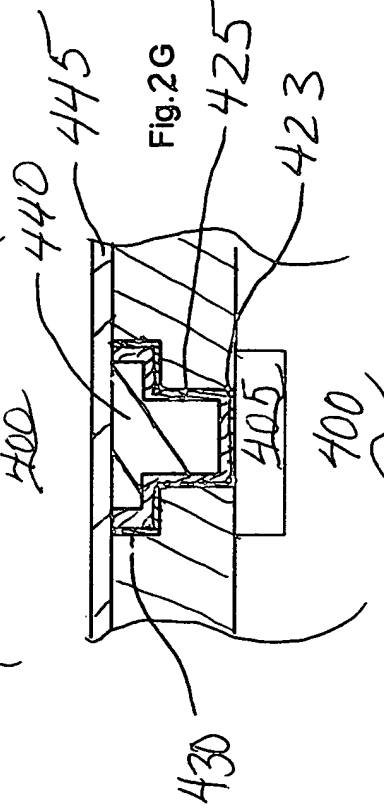


Fig. 2A

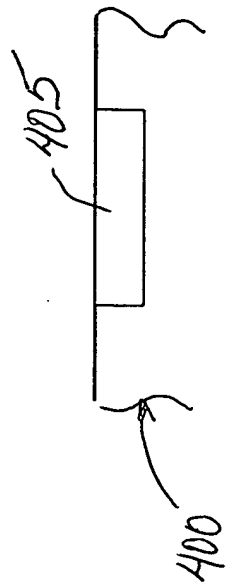


Fig. 2B

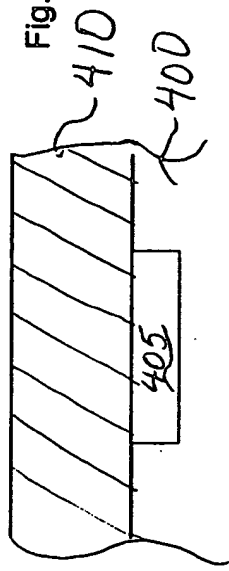


Fig. 2C

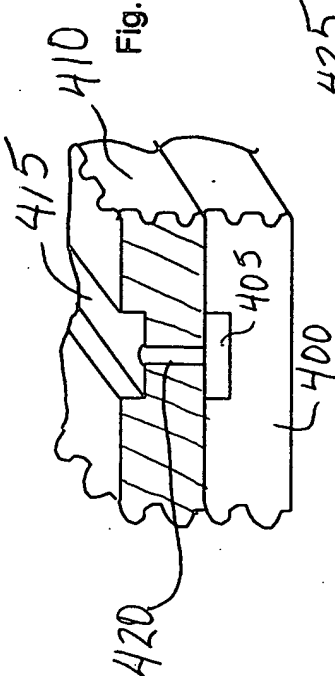
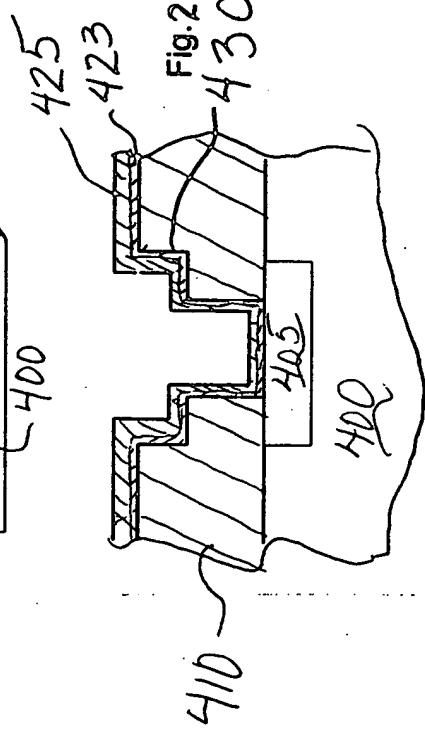


Fig. 2D



Change in Mean Rs over Time

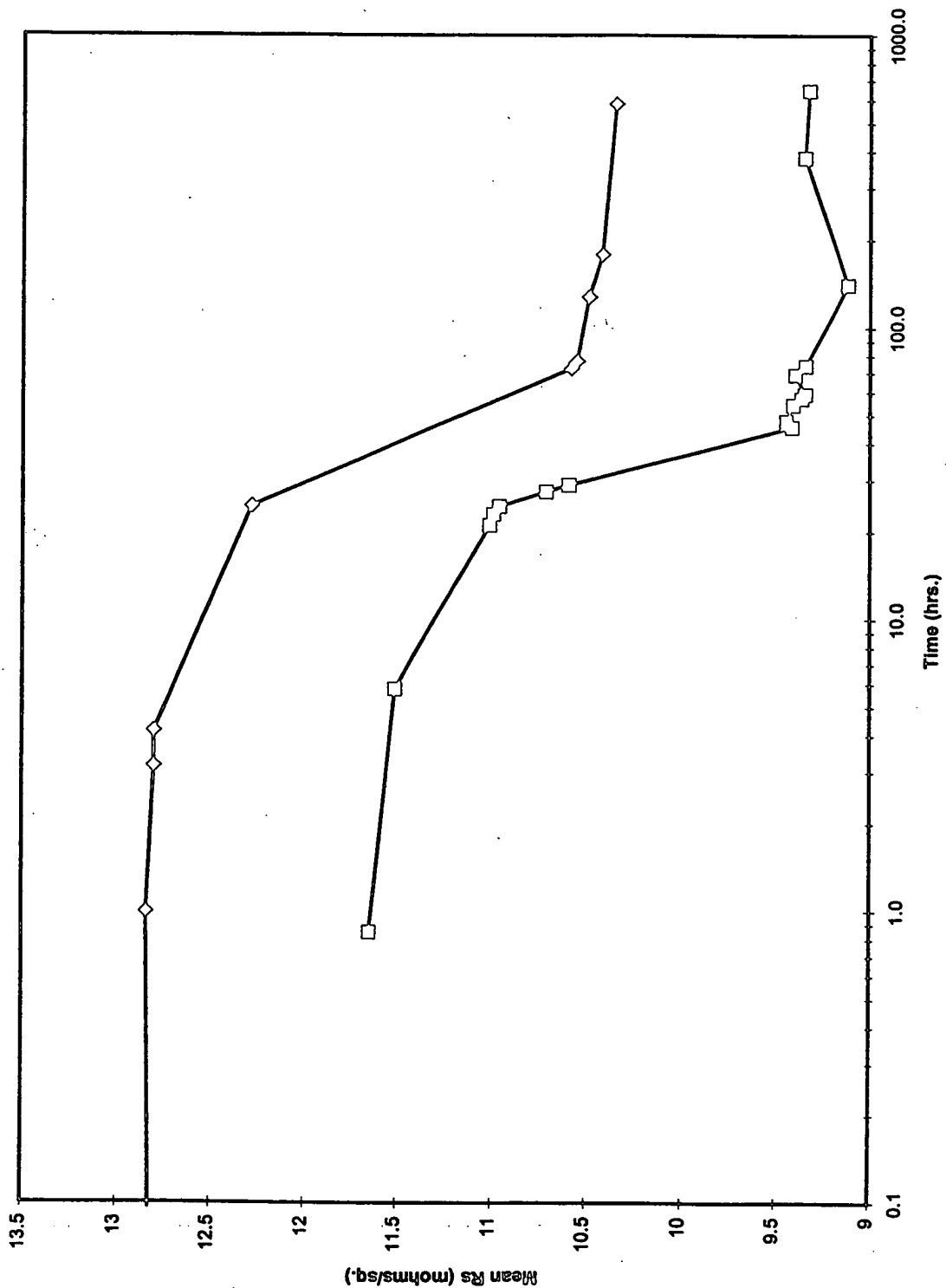


Fig. 3

Two Theta Coupled Scan

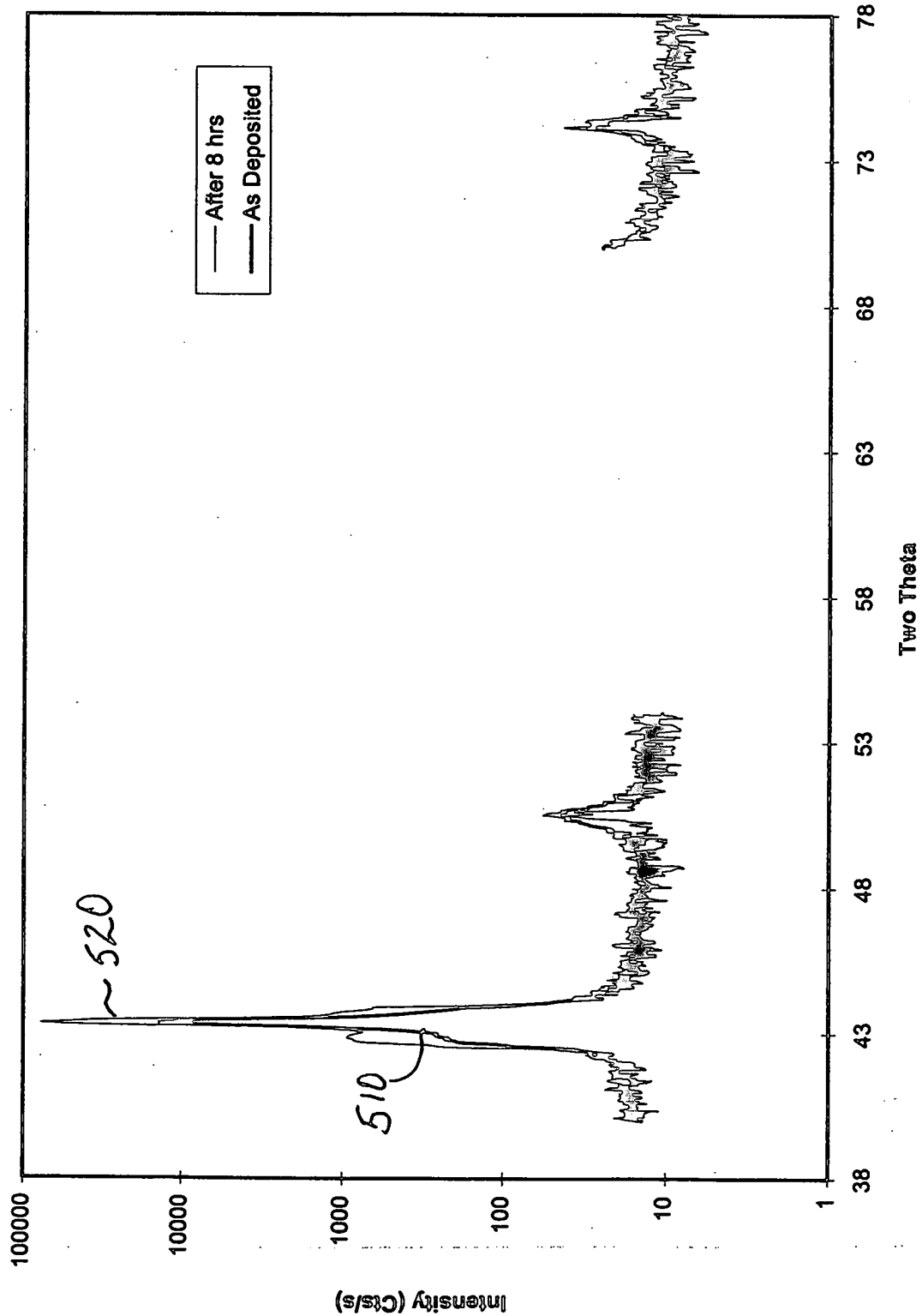


Fig. 4

Rocking Curve

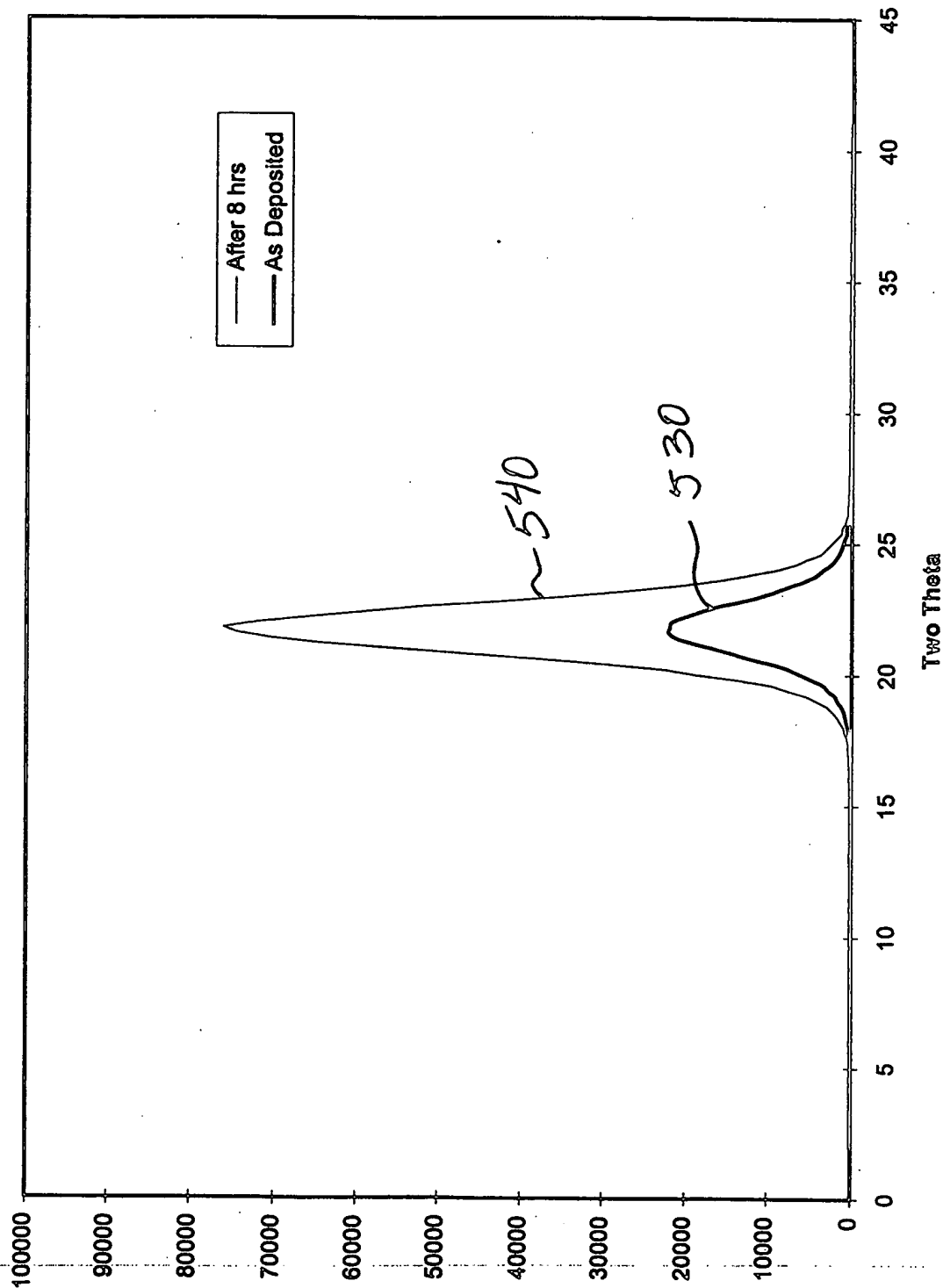


Fig. 5

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Intensity (Cts/s)